



ELECTRONIC COPY

LG770654942
Report verification at igi.org



January 30, 2026

IGI Report Number **LG770654942**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **OVAL BRILLIANT**

Measurements **9.94 X 7.07 X 4.46 MM**

GRADING RESULTS

Carat Weight **2.02 CARATS**

Color Grade **F**

Clarity Grade **VVS 1**

January 30, 2026
IGI Report Number **LG770654942**
Description **LABORATORY GROWN DIAMOND**
Shape and Cutting Style **OVAL BRILLIANT**
Measurements **9.94 X 7.07 X 4.46 MM**

GRADING RESULTS

Carat Weight **2.02 CARATS**

Color Grade **F**

Clarity Grade **VVS 1**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

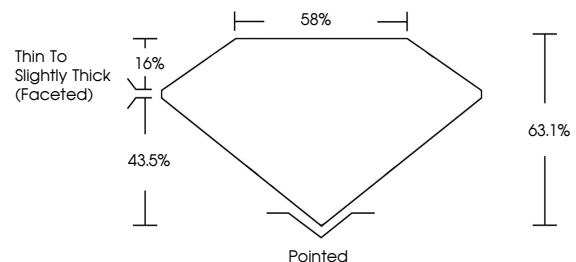
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG770654942**

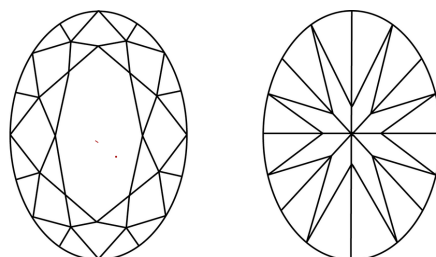
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

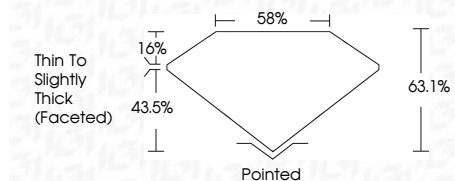
Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

| FL | IF | VVS ¹⁻² | VS ¹⁻² | SI ¹⁻² | I ¹⁻³ |
|----------|---------------------|-----------------------------|------------------------|-------------------|------------------|
| Flawless | Internally Flawless | Very Very Slightly Included | Very Slightly Included | Slightly Included | Included |



ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG770654942**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa



January 30, 2026
IGI Report No LG770654942
OVAL BRILLIANT
9.94 X 7.07 X 4.46 MM
2.02 CARATS
F
Carat Weight
Color Grade
Clarity Grade
Depth
Table
Girdle
Culet
Polish
Symmetry
Fluorescence
Inscription(s)
VVS 1
63.1%
85%
Thin to Slightly Thick (Faceted)
Pointed
EXCELLENT
EXCELLENT
NONE
IGI LG770654942
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa